

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hidetoshi SAITOH et al. Art Unit:
Application No.: filed concurrently Examiner:
Filed : July 8, 2003
Title: PROCESS FOR PRODUCING THIN METAL OXIDE FILM

Mail Stop Patent Application

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to their duty of good faith and candor as set forth in 37 CFR 1.56(a), applicants request that the references cited on attached form PTO-1449 (a copy of which is enclosed) be considered by the Examiner in connection with the search of the prior art required by 37 CFR 1.104.

The English language abstracts for the German patent references are also enclosed.

This Statement is being filed under 37 CFR 1.97(b) prior to the mailing date of a first Office Action on the merits.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached at the telephone number listed below. All correspondence should continue to be directed to our address below.

Respectfully submitted,

Date: July 8, 2003



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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 1

Complete if Known

Application Number	Filed concurrently
Filing Date	July 8, 2003
Applicants	Hidetoshi SAITOH et al.
Group Art Unit	
Examiner Name	
Attorney Docket Number	0052/035002

U.S. PATENT DOCUMENTS

EXAMINER INITIAL*	Cite No. ¹	DOCUMENT NUMBER	Kind Code ² (if known)	NAME	DATE MM-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		3,927,155		JAEGER et al.	12/1975	
		4,975,415		GUSMAN et al.	12/1990	
		5,006,504		O'BRYAN, Jr. et al.	04/1991	
		5,266,243		KNELLER et al.	11/1993	
		5,294,599		SHIBATA et al.	03/1994	
		5,304,536		HOROWITZ	04/1994	
		5,407,618		STEPHENSON	04/1995	
		5,413,988		HAYASHI et al.	05/1995	
		5,534,468		STEPHENSON	07/1996	
		5,614,472		RIDDLE et al.	03/1997	
		5,660,774		STANGLE et al.	08/1997	
		5,728,362		GREUTER et al.	03/1998	
		5,814,585		RIDDLE et al.	09/1998	

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL*	Cite No. ¹	Foreign Patent Document			NAME	DATE MM-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ⁵ (if known)				
		DE	41 27 852	A	MUEHL et al.	02/1993		Abstract
		EP	0 842 911	A	MANZ et al.	05/1998		Abstract

EXAMINER

DATE CONSIDERED

*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²Applicant is to place a check mark here if English language Translation is attached. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.